

Notice of References Cited	Application/Control No. 10/527,789		Applicant(s)/Patent Under Reexamination AIKELE ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0198063	10-2004	Subramanian et al.	438/712
*	B	US-2002/0001871	01-2002	Cho et al.	438/98
*	C	US-6,969,628	11-2005	Bertz et al.	438/48
*	D	US-6,767,614	07-2004	Hofmann et al.	428/166
*	E	US-6,573,154	06-2003	Sridhar et al.	438/430
*	F	US-6,461,888	10-2002	Sridhar et al.	438/52
*	G	US-5,930,595	07-1999	Sridhar et al.	438/52
*	H	US-5,869,354	02-1999	Leedy, Glenn Joseph	438/110
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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